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	Application No.	Applicant(s)
Notice of Allowability	09/834,950	YANO, YOSHIHIKO
Notice of Allowability	Examiner	Art Unit
	Camie S Thompson	1774
The MAILING DATE of this communication app All claims being allowable, PROSECUTION ON THE MERITS IS herewith (or previously mailed), a Notice of Allowance (PTOL-85 NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT R of the Office or upon petition by the applicant. See 37 CFR 1.31	o (OR REMAINS) CLOSED in (i) or other appropriate communication is subjection is subjection in the communication i	this application. If not included
1. X This communication is responsive to After Final Amendme	ent filed 9/23/2004.	
2. The allowed claim(s) is/are <u>9-12,14-17 and 19-21.</u>		
3. ☑ The drawings filed on <u>06 April 2001</u> are accepted by the E		
 4.		(f).
 Certified copies of the priority documents have 		
Certified copies of the priority documents have	e been received in Application	No
Copies of the certified copies of the priority do	cuments have been received	in this national stage application from the
International Bureau (PCT Rule 17.2(a)).		• .,
* Certified copies not received:		
Applicant has THREE MONTHS FROM THE "MAILING DATE" noted below. Failure to timely comply will result in ABANDONN THIS THREE-MONTH PERIOD IS NOT EXTENDABLE.	of this communication to file a IENT of this application.	reply complying with the requirements
5. A SUBSTITUTE OATH OR DECLARATION must be subm INFORMAL PATENT APPLICATION (PTO-152) which give	es reason(s) why the oath or d	IINER'S AMENDMENT or NOTICE OF eclaration is deficient.
6. CORRECTED DRAWINGS (as "replacement sheets") mus	st be submitted.	
(a) ☐ including changes required by the Notice of Draftspers	on's Patent Drawing Review (PTO-948) attached
1) ☐ hereto or 2) ☐ to Paper No./Mail Date		
(b) ☐ including changes required by the attached Examiner's Paper No./Mail Date	s Amendment / Comment or in	the Office action of
Identifying indicia such as the application number (see 37 CFR 1. each sheet. Replacement sheet(s) should be labeled as such in the	84(c)) should be written on the	drawings in the front (not the back) of
 DEPOSIT OF and/or INFORMATION about the deposent attached Examiner's comment regarding REQUIREMENT F 	sit of BIOLOGICAL MATER	IAI must be submitted Note to
Attachment(s)		
1. Notice of References Cited (PTO-892)	5. Notice of Infor	mal Patent Application (PTO-152)
2. ☐ Notice of Draftperson's Patent Drawing Review (PTO-948)	6. Interview Sum	
 Information Disclosure Statements (PTO-1449 or PTO/SB/08 Paper No./Mail Date 	3), 7. ☐ Examiner's An	nendment/Comment
4. ☐ Examiner's Comment Regarding Requirement for Deposit	8. 🛛 Examiner's Sta	atement of Reasons for Allowance
of Biological Material	9.	

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DETAILED ACTION

Claims 9-11, 14-16 and 19-21 are directed to an allowable product. Pursuant to the procedures set forth in the Official Gazette notice dated March 26, 1996 (1184 O.G. 86), claims 12 and 17, directed to the process of making or using the patentable product, previously withdrawn from consideration as a result of a restriction requirement, are now subject to being rejoined. Claims 12 and 17 are hereby rejoined and fully examined for patentability under 37 CFR 1.104.

Since all claims previously withdrawn from consideration under 37 CFR 1.142 have been rejoined, the restriction requirement made in the Office action mailed on November 25, 2003 is hereby withdrawn.

REASONS FOR ALLOWANCE

The following is an examiner's statement of reasons for allowance: The prior art does not provide for an EL panel comprising a fluorescent thin film comprising a matrix material which comprises a rare earth sulfide or a rare earth selenide, and which further comprises a rare earth element as a light emission center, the rare earth element as the light emission center being different from the rare earth element of the matrix material, and wherein said rare earth sulfide comprises at least one compound selected from the group consisting of lanthanum thioaluminate, neodymium thioaluminate and yttrium thioindate. Additionally, the prior art does not provide for the processing of the recited fluorescent thin film by an evaporation technique, wherein: at least, a rare earth metal evaporation source and a group III sulfide evaporation source with a light emission center added thereto are placed in a vacuum chamber with H₂S gas is introduced

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therein, and a rare earth metal and a group III sulfide are evaporated from the respective evaporation sources to deposit a sulfide fluorescent thin film on a substrate while the respective materials are combined with the H₂S gas.

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

Any inquiry concerning this communication or earlier communication from the examiner should be directed to Camie S. Thompson whose telephone number is (571) 272-1530. The examiner can normally be reached on Monday through Friday from 7:30 am to 4:00 pm. If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Rena L Dye, can be reached at (571) 272-3186. The fax phone number for the Group is (703) 872-9306.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

SUPERVISORY PATENT EXAMINER

A-U.1114

1-/18/04